Appl. No. 10/743,985 Amdt. dated 02/28/2007 Response to Office Action of 11/28/2006 Attorney Docket No.: N1085-00168

[TSMC 2003-0219] RECEIVED

CENTRAL FAX CENTER

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

FEB 2 8 2007

In re application of: Shui-Ming Cheng

Examiner: Laura M. Schillinger

Serial No.: 10/743,985

Group Art Unit: 2813

Filed: 12/22/2003

Confirmation No.: 9060

For: BODY CONTACT FORMATION IN PARTIALLY DEPLETED SILICON ON INSULATOR DEVICE

CERTIFICATE OF MAILING/FACSIMILE TRANSMISSION PURSUANT TO 37 C.F.R. §1.8

I hereby certify that this correspondence (and anything referred to as being transmitted herewith) is being facsimile transmitted to the United States Patent and Trademark Office (Fax No. 571-273-8300) on the date shown below.

Date: 두드용 <u>공착,</u> 2007

Mark J. Marcelli

Examiner Laura M. Schillinger Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION DATED NOVEMBER 28, 2006

EXPEDITED PROCEDURE - 37 C.F.R. § 1.116

Commissioner:

Responsive to the Final Office Action dated November 28, 2006, please re-examine and reconsider the above-identified patent application according to the amendments and remarks provided. This response is filed with a Request for Continued Examination pursuant to 37 C.F.R. § 1.114.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.

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